INTEGRATED MONITORING AND CONTROL OF PROCESSING ENVIRONMENT

Abstract

A method of managing components in a processing environment is provided. The method includes monitoring (i) a status of each of one or more computing devices, (ii) a status of each of one or more applications, each application hosted by at least one of the computing devices, and (iii) a status of each of one or more jobs, each job associated with at least one of the applications; determining that one of the status of one of the computing devices, the status of one of the applications, and the status of one of the jobs is indicative of a performance issue associated with the corresponding computing device, application, or job, the determination being made based on a comparison of a performance of the computing device, application, or job and at least one predetermined criterion; and enabling an action to be performed associated with the performance issue.

FIG. 3A